Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the

application.

Please withdraw claims 20-29 with traverse.

Please cancel claims 30-42 without prejudice.

Listing of Claims:

(Original) A method of fabricating a mandrel for electroformation of an

orifice plate, comprising:

creating an array of mask elements adjacent a substrate;

removing surface regions of the substrate disposed generally between the

mask elements to create a base having a base surface and a plurality of pillars

extending from the base surface according to the array of mask elements, each pillar

having a perimeter defined by an orthogonal projection of one of the mask elements

onto the substrate: and

depositing an electrical-conduction enhancer adjacent the base surface and

terminating at least substantially at the perimeter, to create a conductive layer to

support growth of the orifice plate.

2. (Original) The method of claim 1, wherein creating an array of mask

elements includes forming a mask layer adjacent a surface of the substrate and

selectively removing portions of the mask layer complementary to the mask

elements.

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3. (Original) The method of claim 1, wherein removing includes at least

one of wet etching and dry etching the surface regions.

4. (Original) The method of claim 1, wherein removing produces a

plurality of substantially frusto-conical pillars.

5. (Original) The method of claim 1, wherein removing produces a

plurality of pillars have at least substantially planar side surfaces.

6. (Original) The method of claim 1, wherein depositing an electrical-

conduction enhancer includes depositing a metal or a metal alloy onto the base

surface.

7. (Original) The method of claim 1, wherein depositing an electrical-

conduction enhancer includes implanting ions below the base surface and annealing

the substrate to form the conductive layer at positions where the ions were

implanted.

8. (Original) The method of claim 1, wherein depositing an electrical-

conduction enhancer includes depositing the electrical-conduction enhancer onto

substrate surfaces visible along a line of sight generally orthogonal to the base

surface.

9. (Original) The method of claim 1, wherein the pillar includes side

surfaces adjoining the base surface, and wherein removing surface regions includes

undercutting the mask elements to create overhangs disposed above the side

surfaces, and wherein depositing an electrical-conduction enhancer includes

depositing the electrical-conduction enhancer preferentially on the overhangs relative

to the side surfaces.

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10. (Original) The method of claim 1, which further comprises removing the mask elements after depositing.

11. (Original) The method of claim 1, wherein depositing includes terminating placement of the electrical-conduction enhancer within about five micrometers of the perimeter.

12. (Original) A method of fabricating a mandrel for electroformation of an orifice plate, comprising:

creating an array of mask elements adjacent a substrate;

removing surface regions of the substrate disposed generally between the mask elements to create a base having a base surface and a plurality of pillars extending from the base surface according to the array of mask elements, each pillar having side surfaces adjoining the base surface; and

selectively depositing an electrical-conduction enhancer onto the base surface relative to the side surfaces, to create a conductive layer adjacent the base surface to support growth of the orifice plate.

13. (Original) The method of claim 12, wherein depositing an electrical-conduction enhancer on the base surface creates a conductive layer extending adjacent a substantial portion of the base surface and extending adjacent a minor portion or no portion of the side surfaces.

14. (Original) The method of claim 12, wherein the side surfaces include a lower portion beside the base surface and an upper portion spaced from the base surface, and wherein depositing an electrical-conduction enhancer selectively adjacent the base surface includes depositing substantially no electrical-conduction enhancer adjacent the upper portion of the side surfaces.

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15. (Original) The method of claim 12, wherein the side surfaces adjoin the base surface at a base-pillar boundary, and wherein selectively depositing an

electrical-conduction enhancer onto the base surface includes creating a conductive

layer that terminates, at least substantially at the base-pillar boundary.

16. (Original) The method of claim 15, wherein creating a conductive layer

includes creating a conductive layer that terminates within about five micrometers of

the base-pillar boundary.

17. (Original) The method of claim 12, wherein depositing an electrical-

conduction enhancer includes depositing a metal or a metal alloy onto the base

surface.

18. (Original) The method of claim 12, wherein depositing an electrical-

conduction enhancer includes implanting ions below the base surface and annealing

the substrate to form the conductive layer at positions where the ions were

implanted.

19. (Original) The method of claim 12, wherein depositing an electrical-

conduction enhancer includes depositing the electrical-conduction enhancer onto

substrate surfaces visible along a line of sight generally orthogonal to the base

surface.

20. (Withdrawn) A mandrel for electroformation of an orifice plate

produced according to the method of claim 12.

21. (Withdrawn) A mandrel for electroformation of an orifice plate

produced according to the method of claim 1.

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22. (Withdrawn) A mandrel for electroformation of an orifice plate,

comprising:

a base having a base surface;

a plurality of pillars joined unitarily with the base and extending from the base

surface to define an array, each pillar having side surfaces adjoining the base

surface at a base-pillar boundary; and

an electrically conductive layer disposed adjacent the base surface and

terminating at least substantially at the base-pillar boundary.

23. (Withdrawn) The mandrel of claim 22, wherein each pillar tapers away

from the base to define a minimum diameter, the mandrel further comprising a

plurality of mask elements disposed on corresponding pillars, each mask element

having a diameter greater than the minimum diameter of the corresponding pillar to

create an overhang.

24. (Withdrawn) The mandrel of claim 22, wherein the electrically

conductive layer terminates within about five micrometers of the base-pillar

boundary.

25. (Withdrawn) A mandrel for electroformation of an orifice plate,

comprising:

a base having a base surface;

a plurality of pillars joined unitarily with the base and extending from the base

surface to define an array, each pillar having a perimeter defined by an orthogonal

projection of a mask element that guided formation of the pillar; and

an electrically conductive layer disposed adjacent the base surface and

terminating at least substantially at the perimeter.

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- 26. (Withdrawn) The mandrel of claim 25, wherein the electrically conductive layer terminates within about five micrometers of the perimeter.
- 27. (Withdrawn) The mandrel of claim 25, wherein the masked elements are substantially removed.
- 28. (Withdrawn) An orifice plate for an inkjet printhead, the orifice plate having a body portion fabricated using the mandrel of claim 22.
- 29. (Withdrawn) An orifice plate for an inkjet printhead, the orifice plate having a body portion fabricated using the mandrel of claim 25.
 - 30. (Cancelled)
 - 31. (Cancelled)
 - 32. (Cancelled)
 - 33. (Cancelled)
 - 34. (Cancelled)
 - 35. (Cancelled)
 - 36. (Cancelled)
 - 37. (Cancelled)
 - 38. (Cancelled)
 - 39. (Cancelled)
 - 40. (Cancelled)
 - 41. (Cancelled)
 - 42. (Cancelled)

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